



05-07-02

AF/2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant: Peter Van Buskirk, et al.

Application No.: 09/200,495

Date Filed: November 25, 1998

Title: **OXIDATIVE TOP  
ELECTRODE DEPOSITION  
PROCESS, AND  
MICROELECTRONIC  
DEVICE STRUCTURE**

Docket No.: 2771-337 RCE (7482)

Examiner: S. Hu

Art Group: 2811

17/D (P)  
F JONES  
5-10-02RECEIVED  
MAY - 8 2002EXPRESS MAIL CERTIFICATE

I hereby certify that I am mailing the attached documents to the Commissioner for Patents on the date specified, in an envelope addressed to the Commissioner for Patents, Box AF, Washington, D.C., 20231 and Express Mailed under the provisions of 37 CFR 1.10.

Katrina Holland

Signature

May 6, 2002

Date

EV037732777US

Express Mail Label Number

RESPONSE TO FEBRUARY 5, 2002 OFFICE ACTION  
IN U.S. PATENT APPLICATION NO. 09/200,495

Box AF  
Commissioner for Patents  
U.S. Patent and Trademark Office

Sir:

In response to the Office Action dated February 5, 2002 in the above-identified patent application, please amend the application as follows:

Approved by  
S. Hu  
9/25/02